



**ELECTRONIC COPY**

LG680569443  
Report verification at igi.org



February 5, 2025

IGI Report Number **LG680569443**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **9.32 - 9.38 X 5.64 MM**

**GRADING RESULTS**

Carat Weight **3.02 CARATS**

Color Grade **G**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

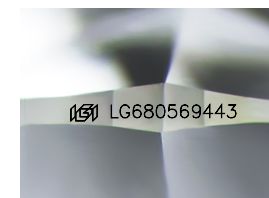
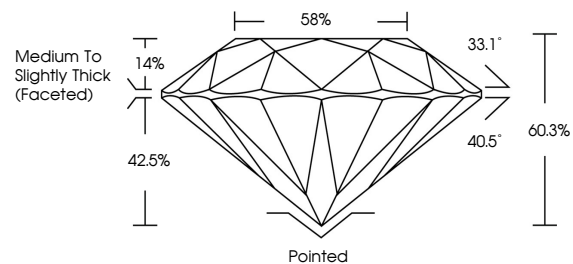
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG680569443**

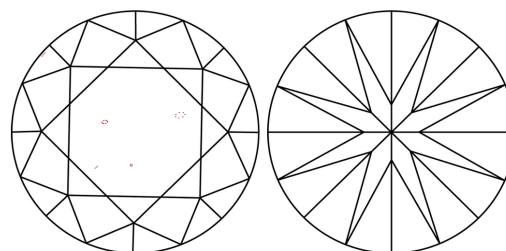
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

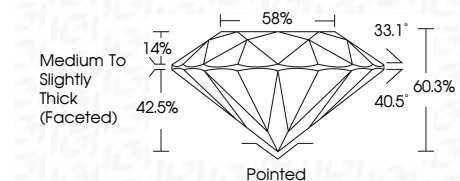
**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF WS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



**ADDITIONAL GRADING INFORMATION**

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Symmetry **EXCELLENT**

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**IGI**



February 5, 2025	IGI Report No LG680569443	3.02 CARATS	G	VS 1	IDEAL	60.3%	58%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG680569443
IGI Report No LG680569443	ROUND BRILLIANT	9.32 - 9.38 X 5.64 MM	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)
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